


**INFORMATION DISCLOSURE
CITATION**

ATTY. DOCKET NO.

SERIAL NO.

2490-17

10/070,619

APPLICANT

MASSARA, A. et al.

FILING DATE

GROUP

March 8, 2002

2881

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
<i>[Signature]</i>	4,873,691	10/1989	Uomi et al	372	20	
<i>[Signature]</i>	4,856,017	08/1989	Ungar	372	96	
<i>[Signature]</i>	5,982,804	11/1999	Chen et al	372	96	

FOREIGN PATENT DOCUMENTS

DOCUMENT	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES NO
2 280 308 A	01/1995	GB			
0 887 668 A1	12/1998	EP			
0 402 907 A2	12/1990	EP			
0 276 071 A2	07/1988	EP			
0 263 690 A2	04/1988	EP			
0 125 608 A2	11/1984	EP			

OTHER DOCUMENTS (including Author, Title, Date, Pertinent pages, etc.)

<i>[Signature]</i>	Massara, A.B. et al; "Mode-hop-free, single-mode operation of 2D-lattice distributed reflector laser under 2.5Gb/s modulation"; Electronics Letters, Vol. 36, No. 2, pp. 141-2; 2000.
<i>[Signature]</i>	Miller, L.M et al.; "A Distributed Feedback Ridge Waveguide Quantum Well Heterostructure Laser"; IEEE Photonics Technology Letters; Vol. 3, No. 1, pp. 6-8; 1991.
<i>[Signature]</i>	Han, H. et al; "Two-Dimensional Rectangular Lattice Distributed Feedback Lasers: A Coupled-Mode Analysis of TE Guided Modes"; IEEE Journal of Quantum Electronics; No. 11; pp. 1947-1954; 1995.
<i>[Signature]</i>	Massara, A.B. et al; "10Gb/s Single-Mode Operation of 2D-Lattice Distributed Reflector Laser"; ECOC 2000; Paper 3-3-5; Munich, 2000.
<i>[Signature]</i>	Masahiro, I. et al; "Semiconductor Lasers with One-and Two-Dimensional Air/Semiconductor Gratings Embedded by Wafer Fusion Technique"; IEEE Journal of Selected Topics in Quant.; pp. 650-663; XP-000930544.
<i>[Signature]</i>	Bullock, D.L. et al; "Photonic band structure investigation of two-dimensional Bragg reflector mirrors for semiconductor laser mode control"; J. Optical Society of America Am. B.; Vol. 10, No. 2; pp. 399-403; XP 000606814.
<i>[Signature]</i>	Watanabe, Y. et al; "Laterally Coupled Strained MQW Ridge Waveguide Distributed-Feedback Laser Diode Fabricated by Wet-Dry Hybrid Etching Process"; IEEE Photonics Technology Letters, Vol. 10, No. 12, 1998; pp. 688-690; XP-000802155.
<i>[Signature]</i>	Toshihiko, M.; "Semiconductor Laser Element"; Patent Abstracts of Japan; 02143581; 01/06/90.
<i>[Signature]</i>	Kiyobumi, C.; "Non-Regrowth Distribution Feedback Ridge Type Semiconductor Laser and its Manufacture"; Patent Abstracts of Japan; 10098235; 04/14/98.

Crossed out already considered on different IDS

*Examiner

Date Considered

4/7/04

Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to application.